



Appl. No. 10/607,869

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/607,869
Filing Date June 27, 2003
Inventor Zhongze Wang
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Jennifer M. Kennedy
Attorney's Docket No. MI22-2343
Customer No. 021567
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

RESPONSE TO MARCH 10, 2005 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Introductory Comments

In reply to the Office Action of March 10, 2005, applicant amends and remarks as follows.